

INFORMATION DISCLOSURE STATEMENT BY APPLICANT <i>(use as many sheets as necessary)</i>				Complete if Known	
				Application Number	10/562,401
				Filing Date	April 5, 2006
				First Named Inventor	Morris
				Art Unit	1793
				Examiner Name	Kevin M. Johnson
Sheet	1C	of	1C	Attorney Docket Number	9013-72

U.S. PATENT DOCUMENTS					
Examiner Initials*	Cite No.	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number-Kind Code (if known)			
	1.	US- 20060032763	02-16-2006	Herman	
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FOREIGN PATENT DOCUMENTS						
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		Country Code, Number, Kind Code (if known)				

NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published	T
	2.	KLIER, Kamil, et al., "No Decomposition in Non-Reducing Atmospheres," Technical Progress Report for the Period December 1995-February 1996, prepared for the United States Department of Energy-Pittsburgh Energy Technology Center, March 1996, pp. 1-14	
	3.	ZHANG et al., "No Adsorbability of Metal Ion-Exchanged Molecular Sieve," Chemical Journal of Chinese Universities, December 1997, pp. 1-6, Vol. 18 – No. 12	Y

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Examiner Signature		Date Considered	
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.